

JUL 18 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
) ATTORNEY FILE NO.:
Inventors: Li et al.) SLA0845
)
Serial No.: 10/761,704) Examiner: Erdem, Fazli
)
Filed: January 21, 2004) Customer No.: 55,286
)
Title: ULTRA-SHALLOW METAL) Group Art: 2826
OXIDE SURFACE CHANNEL)
MOS TRANSISTOR) Confirmation No.: 3680
)

MAIL STOP AMENDMENTS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being facsimile transmitted to the US Patent and Trademark Office, fax No. 571 273 8800, on this date 7/18/2006.

Date 7/18/2006 Signature 

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RESPONSE TO RESTRICTION REQUIREMENT

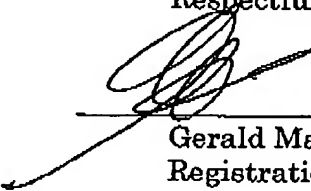
The present communication is responsive to a restriction requirement mailed July 13, 2005, for the above-mentioned application.

The Applicant elects to pursue the Group II Claims, claims 4-8, 11-12, and 24, drawn to a method for making a semiconductor device.

The Applicant cancels claims 16-20 and 23 without traverse.

Respectfully submitted,

Date: 7/18/2006


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